OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Application Data Sheet

Application Information

Application Type::

Regular

Subject Matter::

Utility

CD-ROM or CD-R:

None

Title::

MAGNETO-RESISTANCE EFFECT ELEMENT BAR EXPOSURE METHOD, MAGNETO-RESISTANCE EFFECT ELEMENT BAR FORMATION METHOD AND MAGNETO-RESISTANCE EFFECT ELEMENT BAR

Attorney Docket Number::

116900

Total Drawing Sheets::

5

Small Entity::

No

Applicant Information

Applicant Authority type::

Inventor

Primary Citizenship Country::

Japan

Status::

Deceased Inventor

Given Name::

Tsuneo

Family Name::

KAGOTANI

City of Residence::

Chuo-ku

Country of Residence::

Japan

Applicant Authority type::

Inventor

Primary Citizenship Country::

Japan

Status::

Full Capacity

Given Name::

Hitoshi

Family Name::

HATATE

City of Residence::

Chuo-ku

Country of Residence::

Japan

Applicant Authority type::

Inventor

Primary Citizenship Country::

Japan

Status::

Full Capacity

Given Name::

Noriaki

Family Name::

KASAHARA

City of Residence::

Chuo-ku

Country of Residence::

Japan

Applicant Authority type::

Inventor

Primary Citizenship Country::

Japan

Status::

Full Capacity

Given Name::

Tetsuya

Family Name::

KUWASHIMA

City of Residence::

Chuo-ku

Country of Residence::

Japan

Correspondence Information

Correspondence Customer Number::

25944

Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2002-256110	08/30/2002	Yes
Assignee Information			
Assignee Name::		TDK CORPORATION	
Street of mailing address::		1-13-1, Nihonbashi,	
City of mailing address::		Chuo-ku	
State or Province of mailing address::		Toyko	
Country of mailing address::		Japan	
Postal or Zip Code of mailing address::		103-8272	